

Construction of the Mu3e inner tracking detector

Thomas Rudzki - 22.7.2020 - HighRR seminar

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Introduction

The incomplete Standard Model



The Standard Model (SM) provides no explanation for:

- Gravitation
- Origin of the neutrino masses
- Dark Matter

2 hints in leptonic sector for potential extensions of the SM:

- Neutrino oscillations
- Anomalous magnetic dipole moment of the muon



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 $\alpha = (g - 2) / 2$



The decay $\mu \rightarrow eee$

This decay is strongly suppressed in the SM:

$$\mathcal{B}(\mu \to e\gamma) = \frac{3\alpha}{32\pi} \left(\sum_{i=2,3} U_{\mu i}^* U_{ei} \frac{\Delta m_{i1}^2}{M_W^2} \right)^2 < 10^{-54}$$

An observation of this decay would indicate physics beyond the SM

- Enters via additional couplings
- Would increase cross section significantly





Experimental challenges

Goal: improving limits set by SINDRUM (1988) $\mathcal{B}\left(\mu \to eee\right) < 1 \cdot 10^{-12}$

- High muon rate required
- Fast detection and readout
- Excellent background suppression \rightarrow

2 phases foreseen:

- Using an existing beam line:
- Upgrading detectors + new beamline: $\mathcal{B}(\mu \rightarrow eee) < 10^{-16}$ Ш.



 $\mathcal{B}\left(\mu \to eee\right) \le 10^{-15}$



The Mu3e experiment





Discriminating signal and background



Signal channel



Discriminating signal and background



1x e⁻ from Bhabha scatt.

1x e^+ from $\mu \rightarrow evv$



Discriminating signal and background

Resolution of invariant mass 10¹⁵ muon stops Mu3e Phase I Simulation at 10⁸ muons/s 10^{2} Events / 0.2 MeV/c² Suppression of the decay $\mu \rightarrow eeevv$ $\mu \rightarrow eee$ at 10⁻¹² Resolution of < 1 MeV required Dominated by multiple Coulomb scattering at 10⁻¹³ Bhabha +Michel at 10⁻¹⁴ ⇒ less material at 10⁻¹⁵ 10^{-2} Suppression of accidental background ⇒ fast detectors 10^{-4} 100 ⇒ less material 95 105 110 m_{rec} [MeV/ c^2]

Preliminary sensitivity study from the to-be-published Mu3e TDR

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How to realize low material budget

Monolithic pixel sensors

- HV-MAPS (high-voltage monolithic pixel sensors)
- 50 µm thin
- Efficiency > 99 %
- Time resolution < 20 ns



Ultra-thin support structure

- High-density interconnects (HDI)
- 50-80 µm thin Kapton-aluminum flexprints
- Guide signals and power lines



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Nice CAD drawing









Thermal-mechanical mockup₁₄









HDIs

- \sim 80 µm thin flexprints
- Guide power, HV, and signals
- Sensors are glued on one side
- Electrical connection via spTAB bonding

High-density interconnect for Si heater chips

Glue 5 µm Al 14 µm

PI 10 μm

Al 14 µm

PI 10 μm

Glue 5 µm

PI 25 µm

Layer stack of LTU hdi





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MuPix10/11 sensor

- HV-MAPS (high-voltage monolithic pixel sensors)
- 256x250 pixels (~2x2 cm²)
- 80x80 µm² pixel size
- Minimalist approach of needed connections:
 - 1 HV line
 - 1 power input
 - 1 reference clock
 - 1 slow control
 - 1 to 3 data outputs
- Design and characterization by HighRR fellows: Alena Weber, David Immig, Heiko Augustin









POWERING & SIGNAL TRANSMISSION

Powering concept

Situation:

- Power supplied by custom DC-DC converters (Uni Mainz)
 Intrinsic ripple on power input (10-20 mV, 1 MHz)
- No space for filter components
- Distance to sensor: 50-100 cm
- 12/15 sensors powered by 1 DC-DC converter

Questions:

- Sensors working despite ripple?
- Sensors disturbing each other?





DC-DC board prototype

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Output ripple of DC-DC prototype

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Powering studies

- MuPix test boards optimized for development
 - A lot of filtering on the boards
 - $\circ \quad \text{HAMEG power supply} \\$
 - \circ Supply voltages are 1.8/1.0 V
 - MuPix prototypes have 3 individual supply voltages
 - ▷ Only 1 channel for final sensor
- Remove all filter components
- Supply all power via 1 DC-DC converter only
- Test
 - sensor operationable?
 - Noise and efficiency behaviour



Sensor working without filter components

on board

• Noise stable

Powering studies

Laboratory measurements

- Eye diagrams of data output fine
- Running at low thresholds





0.62 0.64 0.66 0.68

Threshold [V]

4000

3000

2000

1000

±5000

g4000

3000

2000

1000

0.56

0.54

0.58

0.6

Powering studies

Laboratory measurements

- Sensor working without filter components on board
 - Noise stable
 - Eye diagrams of data output fine
 - Running at low thresholds
- Two sensors powered in parallel also working fine
- Ready to test efficiency and noise in testbeam at DESY





by 1 DC-DC converter



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Powering studies

Testbeam campaign in December 2019

Powering studies

Testbeam campaign in December 2019

Testbeam intermezzo:





hit only in DUT

⇒ noise

Powering studies

Testbeam campaign in December 2019







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Data transmission

Studies last winter by Lars Noehte (arXiv:2003.11077)

Data output could be retrieved after a 24 cm long HDI (max. for outer tracking layers)



MuPix8 Insert

1cm cut

1111 -010



Studied:

- MuPix8 can be operated being powered by the DC-DC converter
- MuPix8 can be operated on HDI
- Two sensor do not disturb each other

To be studied:

- Power sensor on HDI by DC-DC converter
- Operate multiple sensors on HDI (autumn 2020)
- Operate final sensor (has to be submitted)
- Frequency behaviour of final supply chain







Gaseous helium cooling

Reason for choice:

- Low material budget
- High thermal conductivity (i.e. 5x higher than air)

Requirement:

Max. temperature 70°C
 ⇒ glass transition of glue



Gaseous helium cooling

Realization:

- 2 g/s helium flow for inner tracker
 ⇒ velocity = 10 m/s
- Allows for heat dissipation of 400 mW/cm²
 ⇒ ~2 Watt per sensor ⇒ >200 Watt only for inner tracker
- Periphery of sensor dissipates more heat than active pixel matrix



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For the **outer tracking** layers Max. 6 kW heat dissipation

8

0...

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Tapeheater program

- Construction of inner tracker mockup to study cooling concept
- Aluminized polyimide tapes equipped with 50 µm thin steel plates
- Heating loop engraved with laser cutter

DED

0-0





Tapeheater program

- Construction of inner tracker mockup
- Aluminized polyimide tapes equipped with 50 µm thin steel plates
- Heating loop engraved with laser cutter
- Mockup constructed and tested in Heidelberg
- Cooling studies performed at FHNW in Brugg (Switzerland) by Marin Deflorin




Tapeheater program

Simulations were carried out for baseline geometry





Additional helium flow around layer 2 using a mylar tube Thomas Rudzki, 22.7.2020



Tapeheater program

Simulations were carried out for baseline geometry



Helium flow only between layer 1 & 2

Additional helium flow around layer 2 using a mylar tube

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Tapeheater program

Simulations were verified with the thermal-mechanical mockup

- Temperatures in simulation and measurement do agree
- Underlines necessity of additional helium flow



Mockup heated with 390 mW/cm², cooled with helium. Measurement with thermal camera

Current status of helium cooling



- Last month, durable cooling with circulating helium was realized in Brugg
 - Stable operation
 - Maximum temperature difference of inlet to sensors around 50 K
- Test of another mockup (silicon heater) foreseen in September/October

...more on this later...

• Transfer of helium cooling system to PSI after this study





The Mu3e inner tracking detector



RADIATION TOLERANCE

Irradiation studies

Motivation:

Polyimide is deemed to be a radiation-hard material *But*...

Observations of brittle polyimide in particle physics experiments and aerospace application

→ Either in inert atmosphere (e.g. helium) or vacuum + ionizing radiation

Mu3e:

- → Polyimide serves as support structure of tracking detector
- → Inert atmosphere (helium) surrounding the material
- → Irradiation by low-energetic electrons (few MeV)



Estimated dose in polyimide



- Simulate absorbed dose in innermost tracking layer
 - Using Geant4
 - Updated the tracker and beampipe geometry of the mu3e simulation
- Dose normalized to 10¹⁵ stopped muons on target (full phase I)
- Expected beam profile from simulations



Dose map terminology



SegmentID = 0,1,2,3,4,5,6,7,8,9,10,11,12,13,14,15,16,17,18





DS



Dose map for Layer 1

Kapton Dose (Layer 1)



Beam pipe & target







Dose map for Layer 1

Kapton Dose (Layer 1)



Setup

- Parasitic testbeam during aging studies of SiPMs for Mu3e
- Box with 20x polyimide targets flushed with helium
- Polyimide only material inside box to minimize remnants





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Setup

- Parasitic testbeam during aging studies of SiPMs for Mu3e
- Box with 20x polyimide targets flushed with helium
- Polyimide only material inside box to minimize remnants









Expected dose for 3 weeks of beamtime

14 strips (2 x 20 mm²) of 25 µm thick Kapton





Expected dose for 3 weeks of beamtime

Geant4 simulations to estimate dose rate:

Last layer of polyimide gets up to ~0.025 Gy/s

3 weeks

⇒ 45 kGy maximally achievable

Up to 60 kGy expected for Mu3e phase I



Kapton Flap Dose per second

Outlook on irradiation study



- Ongoing irradiation campaign as calibration for Mu3e-like irradiation
- Higher doses achieved by strong beta source at PSI
- No strict time limitations





From preparation to construction

Main challenges

- Placement precision (chip-to-chip distance)
 - 80 μm for Si heater / 40 μm for MuPix sensors (optimised for smallest possible gap)
 - 5 µm precision required
- Glue thickness
 - As little material budget as possible
 - Goal: 5 µm glue thickness
- All bonds working
 - SpTAB bonding has to work for each connection
- Glue ladders together to barrel
- Establish all connections to the outside world



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Sensor placement





- Chip confinement while placing on chuck necessary
- Gap between chips: $80 \pm 5 \mu m$ (Si heater)

 $40 \pm 5 \,\mu\text{m}$ (MuPix)

Sensor placement



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Some time for my YouTube career



https://www.youtube.com/watch?v=0SYqHSbH3U4& feature=emb_logo



Precision?





Measuring the gap size

- Digital microscope
- Resolution: 1.5 µm
- Costs ~ 700-800 €
- USB interface





Measuring the gap size



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Placement precision (chip-to-chip distance)

- 80 μ m for Si heater / 40 μ m for MuPix sensors (optimised for smallest possible gap)
- \circ 5 µm precision required

Glue thickness

Main challenges

- As little material budget as possible
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The Hammer & The Dance



Glue Thickness and Standard Deviation



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Si heater tester



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ladder	General remarks	thickness	distances	bad bonds
161-1-3	Some Si broke off at 1 sensor (maybe usable)	No Q&A	~ 100 µm	2x Power #1
161-1-4	Good to use	μ = 14 μm	~ 100 μm	Temp. #1
161-1-5	Two broken sensors	μ = 10 μm	~ 80 µm	Not tested
161-1-6	Good to use	μ = 7 μm	~ 80 µm	-
161-1-2	Good to use	μ = 8 μm	~ 80 µm	-
161-2-1	Good to use	μ = 5 μm	~ 80 µm	-
161-2-2	Good to use	μ = 5 μm	~ 80 µm	-
161-2-3	Good to use	μ = 7 μm	~ 80 µm	-
161-2-4	#1 broken (might be usable)	μ = 8 μm	~ 80 µm	-
161-2-5	Good to use	μ = 6 μm	~ 80 µm	Temp. #4 (#37)
161-2-6				
161-2-7				
161-2-8				
161-2-9				
161-2-10				
161-2-11				
296-1-1	Good to use	μ = 6 μm	~ 80 µm	-
296-2-1	Two broken sensors	μ = 7 μm	~ 80 µm	Not tested
296-2-2	Good to use	μ = 6 μm	~ 80 µm	-
296-2-3	Good to use	μ = 7 μm	~ 80 µm	-
296-2-4	#6 broken (might be usable)	μ = 8 μm	~ 80 µm	Temp. #6
296-2-5	In production		~ 80 µm	

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Main challenges

80 µm for Si heater / 40 µm for M
5 µm precision
After summer holidays :-)
After bonding has to work for each connection

Placement precision (chip-to-chip distance)

- Glue ladders together to barrel
- Establish all connections to the outside world





2020:

Outlook

- 6x MuPix10 on HDI (flexes will arrive late summer/autumn)
- Construct an inner tracker out of test PCBs carrying 6x MuPix10
 - Demonstrator for test run in Mu3e magnet in December

2021:

• Construction of final inner tracker with MuPix11





backup




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Broken sensors





Dose rate for all polyimide layers (irrad setup)

Kapton Flap Dose per second









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1. Formation of radicals in irradiated material





Time

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- 1. Formation of radicals in irradiated material
- 2. Reaction of radicals **Inert atmosphere:**

Radicals decompose material and/or creates cross-links





- 1. Formation of radicals in irradiated material
- 2. Reaction of radicals Inert atmosphere:

Radicals decompose material and/or creates cross-links

Oxygenic atmosphere: Radicals react with O_2 , annealing effect, no decomposition





- 1. Formation of radicals in irradiated material
- 2. Reaction of radicals Inert atmosphere:

Radicals decompose material and/or creates cross-links

Oxygenic atmosphere: Radicals react with O₂, annealing effect, no decomposition



Tool tilted by 30° Basis Sled

Tool is tilted



Gravitation helps to confine chip in one direction





Chip is moved to desired position (confined by sled)





Chip is fixed by vacuum









2nd chip is placed on tool





Chip is fixed by vacuum





and so on ...

Measuring the gap size



- Measurement revealed that chips are too wide by ~25 μm
- Gap shrinks after glueing by 5 µm
- Effect is reproducible





The Mu3e inner tracking detector



Inner tracker support





HDIs







MuPix sensors

